

Day : Wednesday

Date: 6/15/2005
Time: 09:56:21**PALM INTRANET****Inventor Name Search Result**

Your Search was:

Last Name = ZHENG

First Name = LU

| Application# | Patent# | Status | Date Filed | Title | Inventor Name 8 |
|--------------------------|------------|--------|------------|--|-----------------|
| 60040944 | Not Issued | 159 | 03/17/1997 | ACCESSORY APPARATUS AND METHODS | ZHENG, LU |
| 60040943 | Not Issued | 159 | 03/17/1997 | INTELLIGENT PNEUMATIC FLOW-CONTROL VALVE AND RELATED METHODS | ZHENG, LU |
| 60031666 | Not Issued | 159 | 11/21/1996 | BARIATRIC TREATMENT SYSTEM AND RELATED METHODS | ZHENG, LU |
| 60031408 | Not Issued | 159 | 11/18/1996 | BARIATRIC TREATMENT SYSTEM AND RELATED METHODS | ZHENG, LU |
| 60004816 | Not Issued | 159 | 10/05/1995 | ANGIOGENESIS USING HEPATOCYTE GROWTH FACTOR | ZHENG, LU P. |
| 10200824 | 6847244 | 150 | 07/22/2002 | VARIABLE DUTY CYCLE CLOCK GENERATION CIRCUITS AND METHODS AND SYSTEMS USING THE SAME | ZHENG, LUO |

Inventor Search Completed: No Records to Display.

| | | |
|---------------------------------|---------------------------------------|---------------------------------|
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| | <input type="text" value="Zheng"/> | <input type="text" value="Lu"/> |
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| | | | | GROWTH TO TARGET DIAMETER GROWTH | |
|-----------------|------------|-----|------------|--|-------------------|
| <u>09370349</u> | Not Issued | 161 | 08/06/1999 | OPEN-LOOP METHOD AND SYSTEM FOR CONTROLLING GROWTH OF SEMICONDUCTOR CRYSTAL | KIMBEL, STEVEN L. |
| <u>09287916</u> | 6241818 | 150 | 04/07/1999 | METHOD AND SYSTEM OF CONTROLLING TAPER GROWTH IN A SEMICONDUCTOR CRYSTAL GROWTH PROCESS | KIMBEL, STEVEN L. |
| <u>09053164</u> | 5968263 | 250 | 04/01/1998 | OPEN-LOOP METHOD AND SYSTEM FOR CONTROLLING GROWTH OF SEMICONDUCTOR CRYSTAL | KIMBEL, STEVEN L. |
| <u>08725861</u> | 5766341 | 150 | 10/04/1996 | A METHOD FOR ROTATING A CRUCIBLE OF A CRYSTAL PULLING MACHINE | KIMBEL, STEVEN L. |
| <u>08694157</u> | 5779791 | 150 | 08/08/1996 | PROCESS FOR CONTROLLING THERMAL HISTORY OF CZOCHRALSKI-GROWN SILICON | KIMBEL, STEVEN L. |
| <u>08488924</u> | 5593498 | 150 | 06/09/1995 | APPARATUS FOR ROTATING A CRUCIBLE OF A CRYSTAL PULLING MACHINE | KIMBEL, STEVEN L. |

Inventor Search Completed: No Records to Display.

| | | |
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| Search Another: Inventor | Last Name | First Name |
| | <input type="text" value="Kimb"/> | <input type="text" value="Steven"/> |
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Day : Wednesday

Date: 6/15/2005
Time: 09:59:52**PALM INTRANET****Inventor Name Search Result**

Your Search was:

Last Name = KIMBEL

First Name = STEVEN

| Application# | Patent# | Status | Date Filed | Title | Inventor Name 23 |
|-----------------|------------|--------|------------|--|-------------------|
| <u>60577722</u> | Not Issued | 159 | 06/07/2004 | METHOD AND APPARATUS FOR GROWING SILICON CRYSTAL BY CONTROLLING THE MELT SOLID INTERFACE SHAPE AS A FUNCTION OF AXIAL LENGTH | KIMBEL, STEVEN L. |
| <u>60425546</u> | Not Issued | 159 | 11/12/2002 | PROCESS FOR PREPARING SINGLE CRYSTAL SILICON USING CRUCIBLE ROTATION TO CONTROL TEMPERATURE GRADIENT | KIMBEL, STEVEN L. |
| <u>60362379</u> | Not Issued | 159 | 03/07/2002 | METHOD AND APPARATUS FOR SLICING SEMICONDUCTOR WAFERS | KIMBEL, STEVEN L. |
| <u>60301767</u> | Not Issued | 159 | 06/28/2001 | PROCESS FOR PREPARING DEFECT FREE SILICON BY CONTROLLING THE AVERAGE AXIAL TEMPERATURE GRADIENT | KIMBEL, STEVEN L. |
| <u>60264415</u> | Not Issued | 159 | 01/26/2001 | LOW DEFECT DENSITY SILICON SUBSTANTIALLY FREE OF OXIDATION INDUCED STACKING FAULTS | KIMBEL, STEVEN L. |
| <u>60125456</u> | Not Issued | 159 | 03/22/1999 | METHOD AND SYSTEM FOR CONTROLLING DIAMETER OF A SILICON CRYSTAL IN A LOCKED SEED LIFT GROWTH PROCESS | KIMBEL, STEVEN L. |
| <u>11005987</u> | Not Issued | 020 | 12/07/2004 | LOW DEFECT DENSITY SILICON HAVING A VACANCY-DOMINATED CORE SUBSTANTIALLY FREE OF OXIDATION INDUCED | KIMBEL, STEVEN L. |

| | | | | STACKING FAULTS | |
|-----------------|------------|-----|------------|---|-------------------|
| <u>10699038</u> | Not Issued | 041 | 10/31/2003 | PROCESS FOR PREPARING SINGLE CRYSTAL SILICON USING CRUCIBLE ROTATION TO CONTROL TEMPERATURE GRADIENT | KIMBEL, STEVEN L. |
| <u>10623967</u> | Not Issued | 071 | 07/21/2003 | METHOD TO MONITOR AND CONTROL THE CRYSTAL COOLING OR QUENCHING RATE BY MEASURING CRYSTAL SURFACE TEMPERATURE | KIMBEL, STEVEN L. |
| <u>10430483</u> | Not Issued | 041 | 05/06/2003 | PROCESS FOR SUPPRESSING THE NUCLEATION AND/OR GROWTH OF INTERSTITIAL TYPE DEFECTS BY CONTROLLING THE COOLING RATE THROUGH NUCLEATION | KIMBEL, STEVEN L. |
| <u>10377271</u> | Not Issued | 041 | 02/28/2003 | METHOD AND APPARATUS FOR SLICING SEMICONDUCTOR WAFERS | KIMBEL, STEVEN L. |
| <u>10054629</u> | 6846539 | 150 | 01/22/2002 | LOW DEFECT DENSITY SILICON HAVING A VACANCY-DOMINATED CORE SUBSTANTIALLY FREE OF OXIDATION INDUCED STACKING FAULTS | KIMBEL, STEVEN L. |
| <u>09684266</u> | 6482263 | 150 | 10/06/2000 | HEAT SHIELD ASSEMBLY FOR CRYSTAL PULLING APPARATUS | KIMBEL, STEVEN L. |
| <u>09661745</u> | Not Issued | 161 | 09/14/2000 | PROCESS FOR SUPPRESSING THE NUCLEATION AND/OR GROWTH OF INTERSTITIAL TYPE DEFECTS BY CONTROLLING THE COOLING RATE THROUGH NUCLEATION | KIMBEL, STEVEN L. |
| <u>09502340</u> | 6776840 | 150 | 02/10/2000 | METHOD OF CONTROLLING DIAMETER OF A SILICON CRYSTAL IN A LOCKED SEED LIFT GROWTH PROCESS | KIMBEL, STEVEN L. |
| <u>09421187</u> | 6203611 | 150 | 10/19/1999 | METHOD OF CONTROLLING GROWTH OF A SEMICONDUCTOR CRYSTAL TO AUTOMATICALLY TRANSITION FROM TAPER | KIMBEL, STEVEN L. |